



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al. Art Unit : 2818
Serial No. : 10/813,530 Examiner : Chuong A. Luu
Filed : March 29, 2004
Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED
ON A NITRIDE COMPOUND SEMICONDUCTOR

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 27, 2005

In reply to the Office Action of September 27, 2005, applicant submits the following
remarks:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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